



PATENT

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant: Cha Deok Dong

Serial No.: 10/720,457

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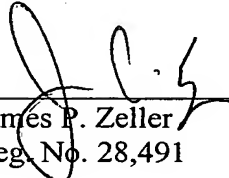
For: METHOD FOR FORMING
DEVICE ISOLATION FILM IN
SEMICONDUCTOR DEVICE

Group Art Unit: 2822

Examiner: Michael M. Trihn

I hereby certify that this paper is being
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July 20, 2006


James P. Zeller
Reg. No. 28,491

RESPONSE TO OFFICIAL ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the claims section begins on page 2 of this paper; and
the remarks begins on page 6 of this paper.